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TATES PATENT AND TRADEMARK OFFICE

In re Application

Inventors:

Andrew Rodney Ferlitsch

Serial No:

09/683,667

Filed:

January 31, 2002

Title:

METHODS AND SYSTEMS FOR PRINT SYSTEM COMPONENT-

BASED REMOTE PRINTING

INFORMATION DISCLOSURE STATEMENT

Attorney Docket No. **SLA1038**

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Technology Center 2100

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on May 24, 2002

> Scott & Krĭeg**ę**r, Reg. No. ¥2,768 re Date May 24/

Commissioner for Patents Washington, D.C. 20231

> INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97(b)

Sir:

Applicants herewith submit information in the above-identified application for consideration by the Examiner. A first Office Action on the merits not having been received, applicants submit this information under 37 C.F.R. §1.97(b)(3).

The information is listed on attached Form PTO-1449 and is submitted pursuant to 37 C.F.R. §1.56. A copy of each listed publication is submitted. The foreign patent documents listed herewith are accompanied by the English-language translations of the abstracts as provided by the Japanese Patent Office. These English-language abstracts may be referred to for a statement of relevance of the associated documents. The inventors, attorney, and any others substantially involved in the preparation or prosecution of this U.S. application are only aware of information in the English-language abstracts and graphical information in the figures of the references.

Applicants respectfully request that the listed information be considered by the Examiner and made of record in the above-identified application.

The Commissioner is hereby authorized to charge any additional fees associated with this communication, or credit any overpayment, to Deposit Account No. 50-0803. A duplicate copy of this authorization is enclosed.

May 24, 2002

Respectfully submitted.

Scott V. Krieger

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Information Disclosure Statement Atty. Docket No. SLA1038

FORM PTO-1449

INFORMATION DISCLOSURE P CITATION IN AN APPLICATION

DOCKET NUMBER **SLA1038**

APPLICANT

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APPLICATION AT IMBER

09/683,667

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FILING DATE:

January 31, 2002

U.S. PATENT DOCUMENTS

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EXAMINER	DOCUMENT	DATE	NAME	CLASS	SUB	FILE, DAT
INITIAL	NUMBER				CLASS	IF APPRO
	5982996	11/9/1999	Snyders	395	114	3/13/199
	5528734	6/18/1996	Sanchez	395	115	5/31/199
	5287194	2/15/1994	Lobiondo	358	296	11/25/19
	5845058	12/1/1998	Shaw et al.	395	114	11/20/19
	6,248,996	06/19/2001	Johnson et al.	250	234	07/12/19
	6,229,622	05/08/2001	Takeda	358	1.16	02/28/19
	2001/0038462 A1	11/8/2001	Teeuwen et al.	358	1.15	12/05/20
- · · · - ·	6,337,745	01/08/2002	Aiello, Jr. et al.	358	1.15	09/05/19
	5,241,397	07/31/1993	Yamada	358	296	12/09/19
<u>. </u>	6,266,150	07/24/2001	Brossman et al.	358	1.15	08/24/19
	5,995,723	11/30/1999	Sperry et al.	395	114	11/18/19
	5,897,260	04/29/1999	Zingher	400	719	01/20/19
	6,157,465	12/05/2000	Suda et al.	358	407	12/29/19
	5,859,711	01/12/1997	Barry et al.	358	296	08/16/19
	2002/0027673		Roosen et al.			08/27/20
	RE37,258	07/03/2001	Patel et al.	358	1.15	10/14/19
	5,978,650	11/02/1999	Fischer et al.	455	3.1	01/21/19
	6,088,120	04/11/2000	Shibusawa et al.	358	1.15	03/26/19
	5,995,721	11/30/1999	Rourke et al.	395	114	06/16/19
	2002/0042798	1	Takei et al.		1	10/05/20

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY/NAME	CLASS	SUB CLASS	TRANSLATION YES NO
04-199218	07/20/1992	Japan			Abstract
10-031750	02/03/1998	Japan			Abstract
10-207643	08/07/1998	Japan			Abstract
11-024860	01/29/1999	Japan			Abstract
2000-151873	05/30/2000	Japan			Abstract
64-014043	01/18/1989	Japan			Abstract
2000-099303	04/07/2000	Japan			Abstract
05-270064	10/19/1993	Japan			Abstract
06-004239	01/14/1994	Japan			Abstract
11-015608	01/22/1999	Japan			Abstract
10-340167	12/22/1998	Japan			Abstract
11-143661	05/28/1999	Japan			Abstract
10-340166	12/22/1998	Japan			Abstract
2000-132347	05/12/2000	Japan			Abstract
09-030040	02/04/1997	Japan			Abstract
10-027149	01/27/1998	Japan			Abstract

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		JUN 0 3 2002 H	sнеет 2 с
 10-187393	07/14/1998	Japan A 8	Abstract
2001-088405	04/03/2001		Abstract
08-101754	04/16/1996	Japan AADEM	Abstract
09-319530	12/12/1997	Japan	Abstract
10-283130	10/23/1998	Japan	Abstract
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			Technology Conter 2003